



PATENT APPLICATION *EC*
1-8-03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshitaka Sasaki, et al.

Group Art Unit: 3729

Application No.: 09/865,445

Examiner: T. Nguyen

Filed: May 29, 2001

Docket No.: 104241.01

For: A METHOD OF MANUFACTURING THIN-FILM MAGNETIC HEAD MATERIAL
(As Amended)

AMENDMENT UNDER 37 C.F.R. §1.111

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

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TECHNOLOGY CENTER R3700

Sir:

In reply to the October 1, 2002 Office Action, please amend the above-identified application as follows:

IN THE TITLE:

Please change the title to --A METHOD OF MANUFACTURING THIN-FILM
MAGNETIC HEAD MATERIAL--.

IN THE ABSTRACT:

Please replace the Abstract as follows:

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--A manufacturing method is provided for manufacturing a head material including: a plurality of rows of head-to-be sections to be thin-film magnetic heads; an inter-row cutting section provided to be a position at which adjacent ones of the rows are to be separated; and an intra-row cutting section provided to be a position at which adjacent ones of the head-to-be sections in each of the rows are to be separated. The method includes the steps of: